

Notice of References Cited	Application/Control No. 10/735,771	Applicant(s)/Patent Under Reexamination HONGO ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,352,469	03-2002	Miyazaki et al.	451/67
*	C	US-6,852,630	02-2005	Basol et al.	438/691
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*	E	US-6,554,205	04-2003	Shinozuka et al.	239/120
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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